



Lessons Learned with Spark at the US Patent & Trademark Office

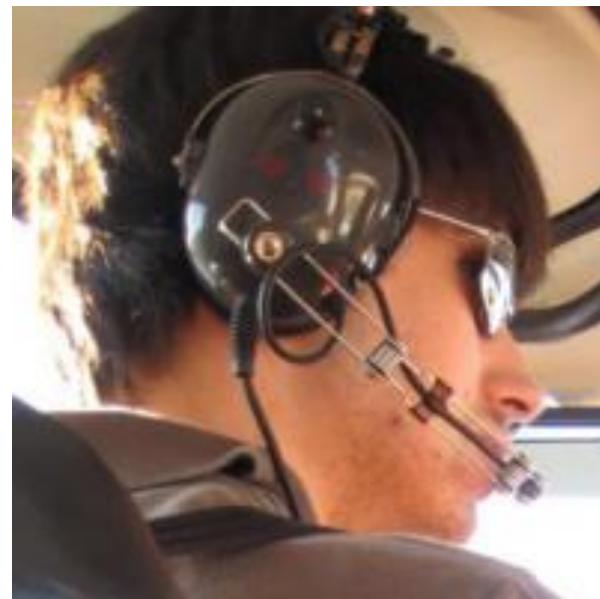
Christopher Bradford

Big Data Architect at OpenSource Connections

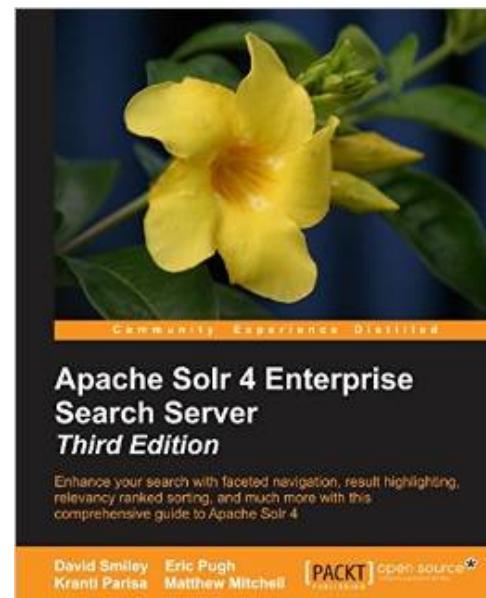
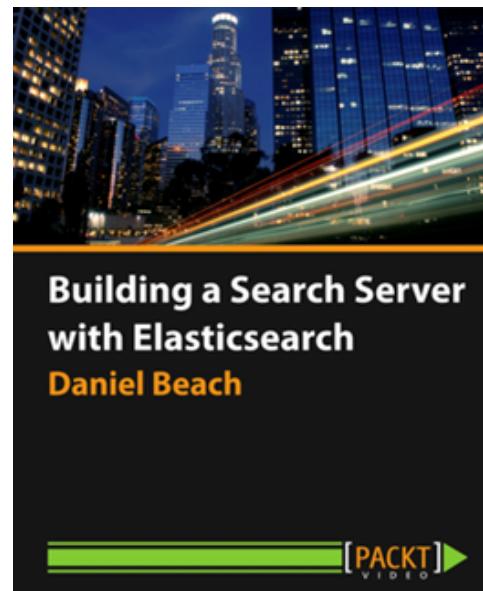
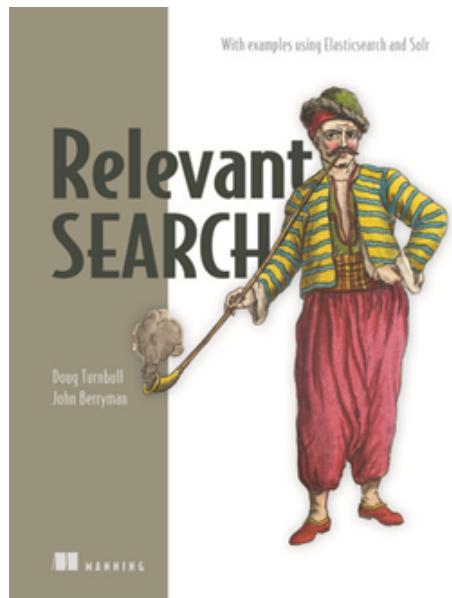
Christopher Bradford

Twitter: @bradfordcp

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OpenSource Connections



Exploring Search Technologies - EST

EST - Prior Art Search

Front-end: 1.14.10-27 SOLR: 4.10.2 API: Sprint264-dirty

Christopher

Hello, anonymous

Prior Art Search

Current Case Number: Untitled Case

Import ... Go to case # Open Close Workspace

Search History

Search

Document Viewer

Text Images

Find within Document

All KWIC « Back Fwd/Back Fwd »

Highlights No highlights found in content below

Search Results

Help

Find within Results

Per Page 100 Sort Date_publ asc Settings

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977 results found. Currently displaying results 1 - 100.

NUMBER	DATE PUBLISHED	CLASS	INVENTOR	TYPE
20010000093	2001-04-05	117/13	Sakurada, Masahiro et al.	Patent

Abstract

There is disclosed a method for producing a silicon single crystal in accordance with the Czochralski method wherein a crystal is pulled with controlling a temperature in a furnace so that .DELTA.G may be 0 or a negative value, where .DELTA.G is a difference between the temperature gradient G_c (degree, C./mm) at the center of a crystal and the temperature gradient G_e (degree, C./mm) at the circumferential portion of the crystal, namely .DELTA.G = $G_e - G_c$, wherein G is a temperature gradient in the vicinity of a solid-liquid interface of a crystal from the melting point of silicon to 1400 degree, C., and with controlling a pulling rate in a range between a pulling rate corresponding to a minimum value of the inner line of OSF region and a pulling rate corresponding to a minimum value of the outer line, when OSF region is generated in an inverted M belt shape in a defect distribution chart which shows a defect distribution in which the horizontal axis represents a diameter of the crystal and the vertical axis represent a pulling rate. There can be provided a method of producing a silicon single crystal wafer by CZ method wherein OSF in the ring shape

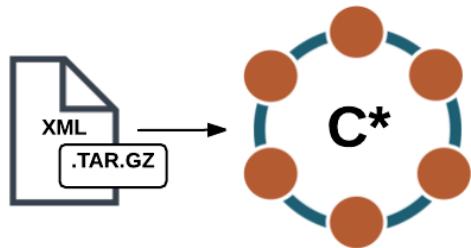


EST – Technology Stack

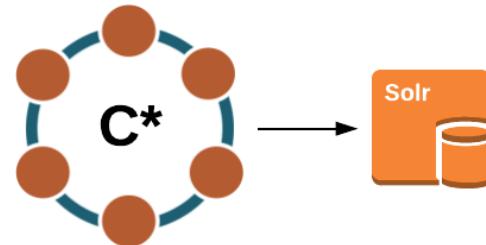


EST – Data Loading

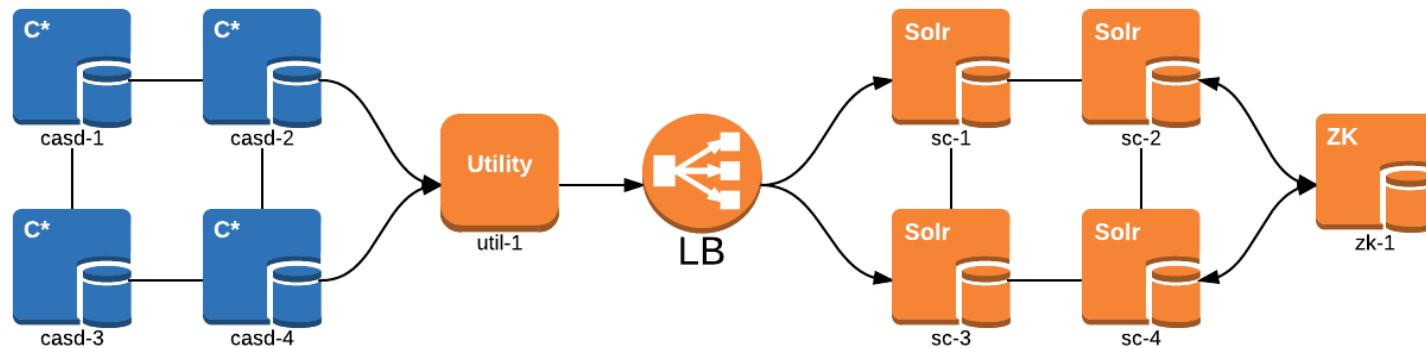
CSS Ingestion (CSS2C)



Solr Ingestion (C2S)



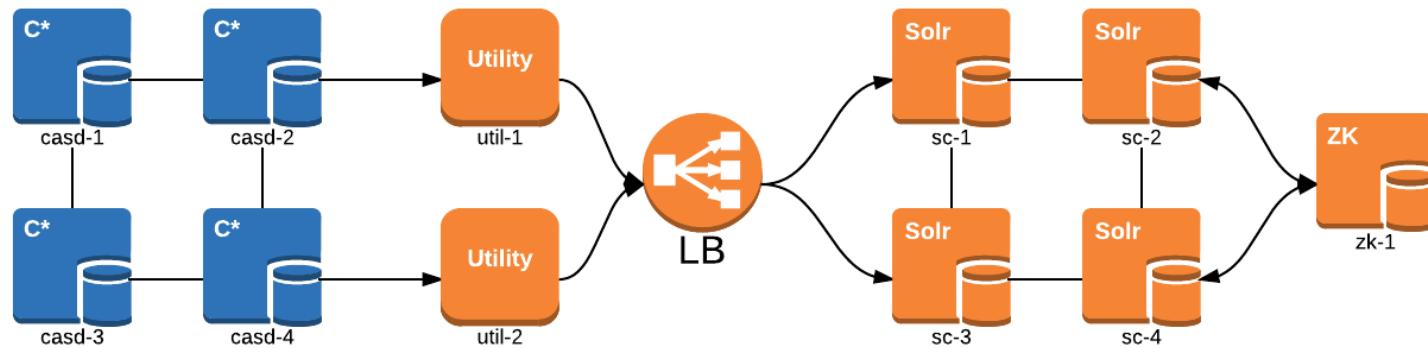
EST – C2S Process



Note: some connections are omitted for clarity

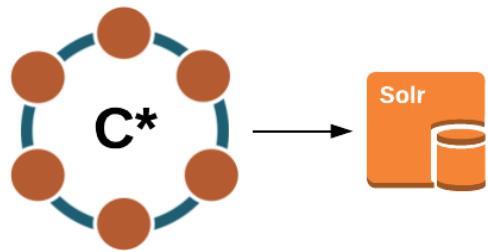


EST – C2S Process (Scaled Out)



Note: some connections are omitted for clarity

EST – C2S Review



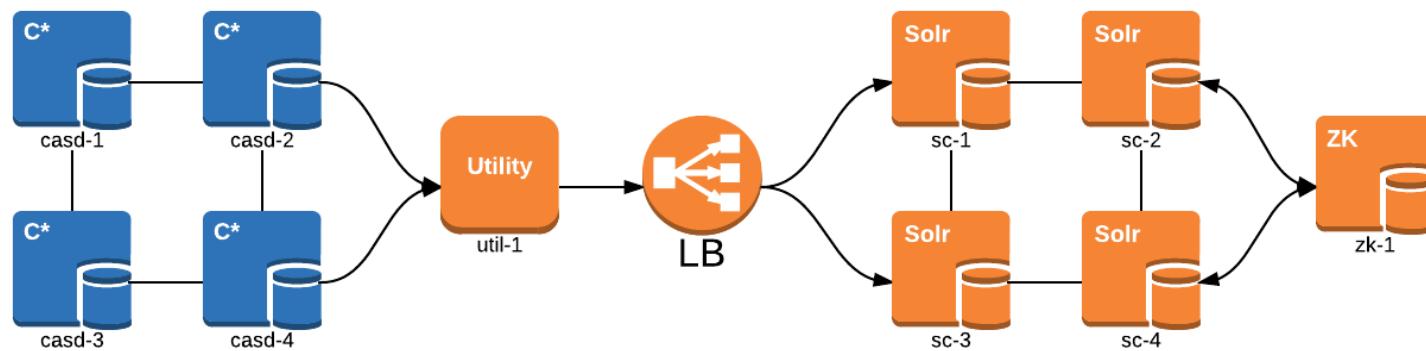
Did it work?
Why change it?
How could we make it better?



Spark



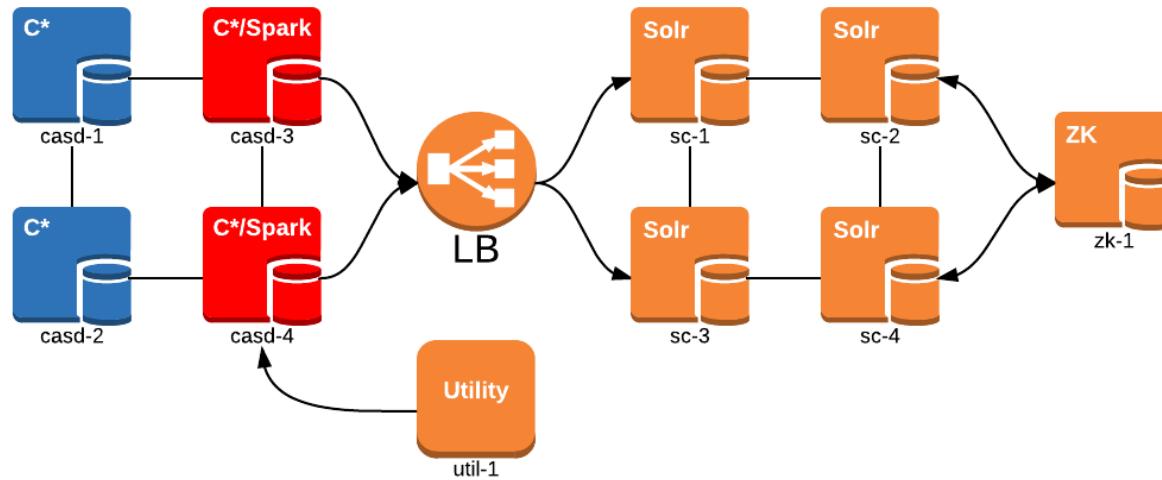
EST – Old C2S Process



Note: some connections are omitted for clarity



EST – Spark C2S Process



Note: some connections are omitted for clarity



How did this work out?

Poorly



Poor Performance

```
joinedRDD = ...
joinedRDD.foreach()
    document = ... // build document
    sc = new SolrConnection()
    sc.push(document)
    sc.disconnect()
// Job is done
```



Poor Performance

```
sc = new SolrConnection()  
sc.push(document)  
sc.disconnect()
```



Optimum Performance

```
joinedRDD = ...  
sc = new SolrConnection()  
joinedRDD.foreach()  
    document = ... // build document  
    sc.push(document)  
sc.disconnect()  
// Job is done
```

```
joinedRDD = ...  
joinedRDD.foreachPartition()  
sc = new SolrConnection()  
partition.foreach()  
    document = ... // build document  
    sc.push(document)  
sc.disconnect()  
// Job is done
```

Almost



The Solution!

```
joinedRDD = ...
joinedRDD.mapPartitions()
  sc = new SolrConnection()
  partition.foreach()
    document = ... // build
    document
    sc.push(document)
  sc.close()
  return partition.rows
.collect()
```

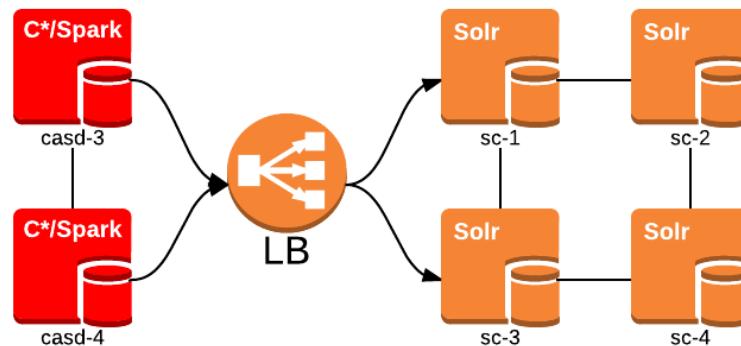
```
joinedRDD = ...
joinedRDD.mapPartitions()
  sc = new SolrConnection()
  partition.foreach()
    document = ... // build
    document
    sc.push(document)
  sc.close()
  return partitions.rows.count
.collect()
```



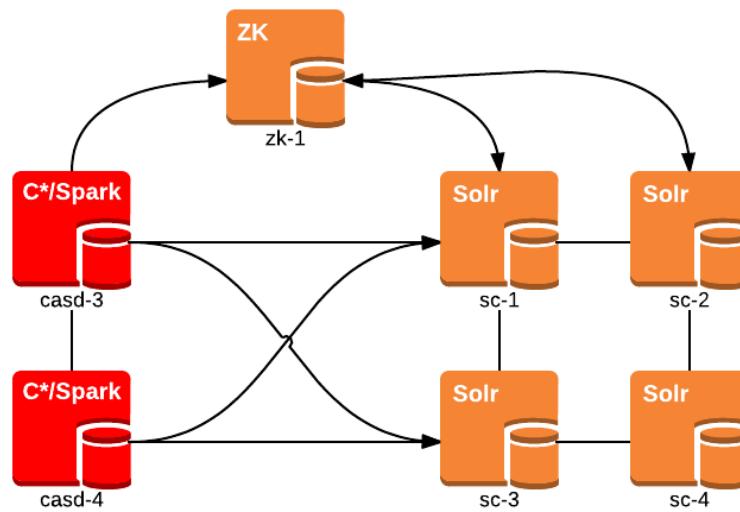
Results?



Solr Indexing

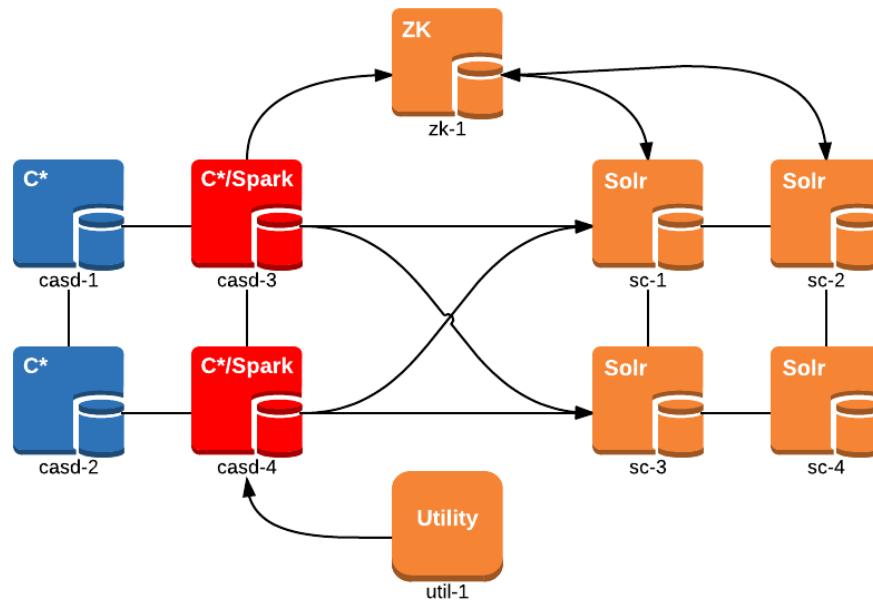


Better Solr Indexing



Note: some connections are omitted for clarity

EST – Spark C2S Process v2



Success?

YUP

5x faster than the original C2S process (with optimizations)



What's Next?

- Optimization of the C2S Spark job
- More Spark jobs
- Newer version of Spark & DSE
- Scala Spark jobs instead of Java

